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Nikolay Guletsky
Apt 167
25/3 Nastavikov Propsect
St. Petersburg, 195030
Russia

In re Application of
ZAIT et al.

U.S. Application No.: 10/564,972

PCT No.: PCT/IL04/00653

Int. Filing Date: 18 July 2004

Priority Date: 18 July 2003

Attorney Docket No.: P-8503-US

For: METHOD FOR CORRECTING CRITICAL DIMENSION VARIATIONS IN
PHOTOMASKS

Dear Nikolay Guletsky:

You are named as an inventor in the above identified United States patent application, filed under the provisions of 37 CFR 1.47(a) and 35 U.S.C. 116. Should a patent be granted, you will be designated as an inventor.

As a named inventor, you are entitled to inspect any paper in the file wrapper of the application, order copies of all or any part thereof (at a prepaid cost per 37 CFR 1.19) or to make your position of record in the application. Alternatively, you may arrange to do any of the preceding through a registered patent agent or attorney presenting written authorization from you. If you care to join in the application, counsel of record (see below) would presumably assist you. Joining in the application would entail the filing of an appropriate oath or declaration by you pursuant to 37 CFR 1.63.

Anthony Smith
Attorney-Advisor
Office of PCT Legal Administration
Telephone: (571) 272-3298
Facsimile: (571) 273-0459

Counsel of Record:
Pearl Cohen Zedek Latzer, LLP
1500 Broadway, 12th Floor
New York, New York 10036